

**Notice of References Cited**

Application/Control No.

10/590,835

Applicant(s)/Patent Under  
Reexamination  
OGAWA ET AL.

Examiner

Peter Y. Choi

Art Unit

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*	B	US-4,719,045	01-1988	Ogawa et al.	252/609
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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